



**ELECTRONIC COPY**

LG733599981  
Report verification at igi.org



October 7, 2025

IGI Report Number **LG733599981**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **8.84 X 6.49 X 4.04 MM**

**GRADING RESULTS**

Carat Weight **1.50 CARAT**

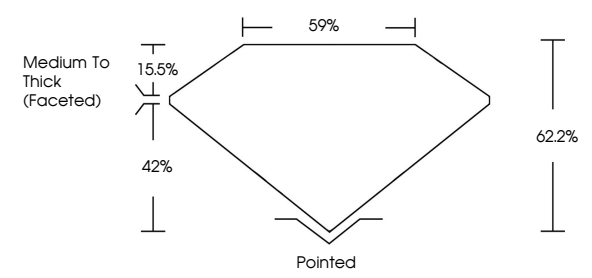
Color Grade **D**

Clarity Grade **VVS 1**

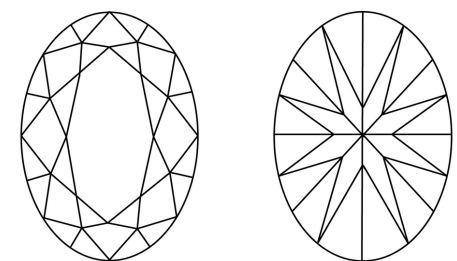


Sample Image Used

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

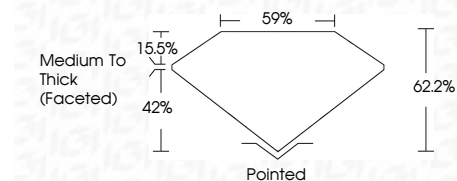
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D	E	F	G	H	I	J	Faint	Very Light	Light
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**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG733599981**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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OVAL BRILLIANT  
8.84 X 6.49 X 4.04 MM  
Carat Weight 1.50 CARAT  
Color Grade D  
Clarity Grade VVS 1  
Depth 42%  
Table 59%  
Girdle Medium To Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG733599981

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